

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**Atty. Docket No.
FOC1100-1

Applicants

Robert Jackson

Application Number

10/038,745

Filed

01/02/2002

For

**METHOD AND SYSTEM FOR ON-SITE GENERATION AND
DISTRIBUTION OF A PROCESS GAS**

Group Art Unit

1754

Examiner

Nguyen, Ngoc Yen M

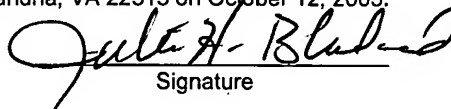
Confirmation No.

2978

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Certification Under 37 C.F.R. §1.8

I hereby certify that this document is being deposited with the United States Postal Service as First Class Mail to Addressee in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on October 12, 2005.



Signature

Julie H. Blackard

Printed Name

Applicant respectfully requests, pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, that the art listed on the attached SBO8-A and B forms be considered and cited in the examination of the above-identified application.

Furthermore, pursuant to 37 C.F.R. §§ 1.97(g) and (h), no representation is made that a search has been made or that this art is material to patentability of the present application. Applicants respectfully submit that the claims of Applicant's above-referenced patent is patentably distinguishable from these references. Applicant believes no fee is due at this time. However, the Commissioner is hereby authorized to charge any fees due, or refund any credit, to Deposit Account No. 50-3183 of Sprinkle IP Law Group for any fee under 37 C.F.R. §1.17.

Respectfully submitted,

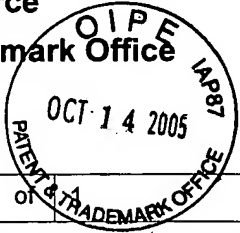
Sprinkle IP Law Group
Attorneys for Applicants



John L. Adair

Reg. No. 48,828

Dated: October 12, 2005
1301 W. 25th Street, Suite 408
Austin, Texas 78705
Tel. 512-637-9220
Fax. 512-371-9088

FORM PTO 1449 US Department of Commerce Patent and Trademark Office 		Application Number	10/038,745	
		Filing Date	01/02/2002	
		First Named Inventor	Robert Jackson	
		Group Art Unit	1754	
		Examiner Name	Nguyen, Ngoc Yen M.	
Sheet	1	Atty Docket Number	FOC1100-1	
Examiner Initials	Cite No.	OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS		Date
	C17	Mickelson, <i>et al.</i> , "Fluorination of Single-Wall Carbon Nanotubes," <i>Chemical Physics Letters</i> 296," pgs. 188-194.		10/30/1998
	C18	Foon and Kaufman, Kinetics of Gaseous Fluorine Reactions, <i>Progress in Reaction Kinetics</i> , Vol. 8, No. 2, pp. 81-93		1975
	C19	C.J. McGab, VLSI Technology, Section 8.3-Dry Etching, McGraw Hill Book Co., pp. 312-317		1983
Examiner Signature				Date Considered